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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Eliezer Pasternack

Serial No. 09/376,867

Group Art Unit: Not yet assigned

Filed:

August 18, 1999

Examiner:

Not yet assigned

Title:

DIRECT DIGITALLY TUNABLE MICROWAVE OSCILLATORS AND

FILTERS

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as FIRST CLASS MAIL in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231, on: January 27, 2000

1/27/00

Date

Patricia K. Parry

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TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT

Commissioner of Patents & Trademarks Washington, D.C. 20231

Sir: \

Transmitted herewith are the following:

- 1) Information Disclosure Statement with PTO 1449 form;
- 2) 7 cited references; and
- 3) Return Postcard.

Authorization is hereby given to charge any underpayment of fees or credit any overpayment of fees related to this communication to Deposit Account No. 07-1896. A duplicate copy of this paper is attached for accounting purposes.

Respectfully submitted,

GRAY CARY WARE & FREIDENRICH LLP

Dated: Carrian 27, 2000

Timothy W. Lohse Attorney for Applicant

Reg. No. 35,255

GRAY CARY WARE & FREIDENRICH LLP

Attn: Patent Department 400 Hamilton Avenue Palo Alto, CA 94301

Telephone: (650) 320-7426





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Hon. Commissioner of Patents and Trademarks Washington, DC 20231

Dear Sir:

Pursuant to 37 CFR §1.56(a), Applicant hereby cites the following supplemental documents (copies enclosed) listed on the attached copy of Form PTO-1449.

This Information Disclosure Statement is filed

(1) Within three months of the filing date of a national application; OR

FEB-4 2000

- (2) Within three months of the date of entry of the national stage of an i international application; OR
 - (3) Before the mailing of a first Office Action on the merits.

No fee or certification is required.

Authorization is hereby given to charge the indicated fee(s) to Deposit Account No. 07-1896. A duplicate copy of this transmittal letter is attached. Please charge any additional fee due for this paper to Deposit Account No. 07-1896.

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GRAY CARY WARE & FREIDENRICH

Dated: Cannary 27, 2000

Timothy W. Lohs

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Sheet 1 of 1

Form PTO-1449 U.S. DEPT. OF COMMERCE	Attorney Docket Number:	Serial Number:
(modified 2/91) Patent and Trademark Office	B0259-1100	09/376,867
INFORMATION DISCLOSURE CITATION		
(Use several sheets if necessary)		
·	Applicant: Eliezer Pasternack	
	Filing date:	Group art unit:
	August 18, 1999	Not assigned
LLS. PATENT DOCUME	ENTS	

Examiner Initial	Patent number	Date	Name	Class	Sub- class	Filing date if approp	riate
	5,608,263	3/4/97	Drayton et al.	257	728	9/6/94 N	
	5,821,836	10/13/98	Katechi et al.	333	202	5/23/97	ñ
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FOREIGN PATENT DOCUMENTS

 Document number	Date	Country	Class	Sub- class	Translation	
					YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

J.B. Muldavin et al., "30 GHz Tuned MEMS Switches", IEEE MTTS 1999
Z. Feng et al., "Design and Modeling of RF MEMS Tunable Capacitors Using Electro-thermal Actuators", IEEE MTTS-1999
H. Kim et al., "Millimeter Wave Micromachined Tunable Filters", IEEE MTTS Digest, pp 1235-1238, 1999
C.T. Nguyen et al., "Micromachined Devices for Wireless Communications", Proceedings of the IEEE, Vol. 86, pp 1756-1768, 1998
J. Yao et al., "High Tuning Ration MEMS-Based Tunable Capacitors for RF Communications Applications", Solid State Sensor and Actuator Workshop, Hilton Head, South Carolina, Jun 8-11, 1998

Examiner:	Date Considered:				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP '609; Draw line through citation					
if not in conformance and not considered. Include copy of this form with next communication to the applicant.					